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PATENT

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February 12, 2003

Date

Ayesha S. Wilks

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Trung T. Doan and Gurtej S. Sandhu    Attorney Docket No.: 500300.02  
Serial No. : 10/054,692    Group Art Unit : 3725  
Filed : December 19, 2001    Examiner : William Hong  
Title : POLISHING PAD REFURBISHER FOR IN SITU, REAL-TIME CONDITIONING  
AND CLEANING OF A POLISHING PAD USED IN CHEMICAL-MECHANICAL  
POLISHING OF MICROELECTRONIC SUBSTRATES

Commissioner of Patents  
Washington, DC 20231

AMENDMENT

Sir:

Please amend the above-captioned patent application as follows:

In the Specification:

Applicants have attached a new specification incorporating the changes in the Certificate of Correction as requested by the Examiner under MPEP 1411.01. The amendment made to the specification is to column 2, line 29 in which "uniformnly" has been changed to read "uniformly".

02/25/2003 HMARZ11 00000018 10054692

01 FC:1201  
02 FC:1202

252.00 OP  
414.00 OP